Docket No.

IN THE UNIT ES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Tsutomu OKABE, et al.

SERIAL NO: 10/706.914

GAU:

1763

FILED:

November 14, 2003

245161US3CIF

EXAMINER: MOORE, KARLA A.

FOR:

WAFER PROCESSING APPARATUS HAVING DUST PROOF FUNCTION

REQUEST FOR EXTENSION OF TIME UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

It is hereby requested that a one month extension of time be granted to June 26, 2007 for		
	filing a response to the Official Action dated: February 26, 2007	
	responding to the requirements in the Notice of Allowability dated:	
	filing the Formal Drawings. The Issue Fee due has been timely filed.	
	responding to the Notice to File Missing Parts of Application dated:	
	filing a Notice of Appeal. A timely response to the final rejection, due has been filed.	
	filing an Appeal Brief. A Notice of Appeal was filed on:	
	Applicant claims small entity status. See 37 CFR 1.27. Therefore, the fee amount shown below is reduced by one-half.	

The required fee of \$120.00 is enclosed herewith by credit card payment and any further charges may be made against

the Attorney of Record's Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

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